

	Type	Hits	Search Text
69	BRS	0	((physical adj vapor adj deposition) or PVD) same metal with substrate) and ((deposition adj chamber) same hydrogen with atmosphere) and (sputter\$4 near3 deposit\$3 with (metal or titanium))
70	BRS	1	((physical adj vapor adj deposition) or PVD) same metal with substrate) and ((deposition adj chamber) same hydrogen with atmosphere)
71	BRS	4	((deposition adj chamber) same hydrogen with atmosphere) and (sputter\$4 near3 deposit\$3 with titanium)
72	BRS	52	((deposition adj chamber) same hydrogen near5 atmosphere) and (sputter\$4 near3 deposit\$3 with metal)
73	BRS	4	((deposition adj chamber) same hydrogen near5 atmosphere) and ((sputter\$4 near3 deposit\$3 with metal) same hydrogen near5 atmosphere)
74	BRS	4	(deposition adj chamber) and ((sputter\$4 near3 deposit\$3 with metal) same hydrogen near5 atmosphere)
75	BRS	31	(deposition adj chamber) and ((deposit\$3 with metal) same hydrogen near5 atmosphere)
76	BRS	3	((physical adj vapor adj deposition) or PVD) with metal) and ((deposition adj chamber) and ((deposit\$3 with metal) same hydrogen near5 atmosphere))
77	BRS	9	(deposition adj chamber) and ((deposit\$3 with metal) with hydrogen near5 atmosphere)
78	BRS	4	(deposition adj chamber) and ((deposit\$3 with metal) same hydrogen near5 nitrogen near5 atmosphere)
79	BRS	17	(deposition adj chamber) and (deposit\$3 with hydrogen near5 nitrogen near5 atmosphere)
80	BRS	0	((physical adj vapor adj deposition) or PVD) and ((deposition adj chamber) and (deposit\$3 with hydrogen near5 nitrogen near5 atmosphere))

	DBs	Time Stamp	Comments	Error Definition	Errors
69	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/29 15:55			0
70	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 15:45			0
71	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/29 15:58			0
72	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 15:37			0
73	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 15:40			0
74	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 15:42			0
75	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 16:19			0
76	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 16:12			0
77	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 15:58			0
78	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 16:07			0
79	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 16:16			0
80	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 16:13			0

	Type	Hits	Search Text
81	BRS	0	(deposition adj chamber) and (deposit\$3 with hydrogen near5 nitrogen near5 atmosphere) same ((physical adj vapor adj deposition) or PVD)
82	BRS	113	deposit\$3 with hydrogen near5 nitrogen near5 atmosphere
83	BRS	4	(deposition adj chamber) and ((deposit\$3 with metal) same (hydrogen near5 nitrogen near5 atmosphere))

	DBs	Time Stamp	Comments	Error Definition	Errors
81	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 16:15			0
82	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 16:16			0
83	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/30 16:21			0